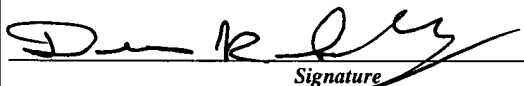

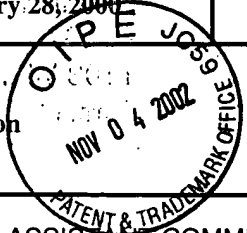


GP/1741

AMENDMENT TRANSMITTAL LETTER (Small Entity)				Docket No. M-11749-4D-US	
Applicant(s): Cohen, Adam L.					
Serial No. 09/493,496	Filing Date January 28, 2000	Examiner Smith-Hicks, Erica D.	Group Art Unit 1741		
Invention: Method For Electrochemical Fabrication					
TO THE ASSISTANT COMMISSIONER FOR PATENTS:					
Transmitted herewith is an amendment in the above-identified application.					
<input type="checkbox"/> Small Entity status of this application has been established under 37 CFR 1.27 by a verified statement previously submitted.					
<input type="checkbox"/> A verified statement to establish Small Entity status under 37 FR 1.27 is enclosed.					
The fee has been calculated and is transmitted as shown below.					
CLAIMS AS AMENDED					
	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	3 -	12 =	0 x	\$9.00	\$0.00
INDEP. CLAIMS	1 -	3 =	0 x	\$42.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00
<input type="checkbox"/> No additional fee is required for amendment.					
<input checked="" type="checkbox"/> Please charge Deposit Account No. 502123 in the amount of \$0.00 A duplicate copy of this sheet is enclosed.					
<input type="checkbox"/> A check in the amount of to cover the filing fee is enclosed.					
<input checked="" type="checkbox"/> The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 502123 A duplicate copy of this sheet is enclosed.					
<input type="checkbox"/> Any additional filing fees required under 37 C.F.R. 1.16.					
<input type="checkbox"/> Any patent application processing fees under 37 CFR 1.17.					
 Dennis R. Smalley Reg. No. 35, 364			Dated: October 25, 2002		
MEMGen Corporation 1103 W. Isabel St. Burbank, CA 91506 Ph: (818) 295-3996, ext. 105 Fx: (818) 295-3998					
cc:					
<div style="border-bottom: 1px solid black; text-align: center;"> Signature of Person Mailing Correspondence</div> <div style="text-align: center;">Dennis R. Smalley Typed or Printed Name of Person Mailing Correspondence</div>					



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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Cohen, Adam L.
Title: Method For Electrochemical Fabrication
Serial No.: 09/493,496
Examiner: Smith Hicks, Erica D. Filing Date: January 28, 2000
Docket No.: M-11749-4D-US Group Art Unit: 1741
(Formerly 06666/010005/2615)

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October 25, 2002

ASSISTANT COMMISSIONER FOR PATENTS
Washington, D.C. 20231

RESPONSE TO OFFICE ACTION

Dear Sir:

Applicant makes this submission in response to the Office Action dated April 25, 2002 for the above noted application for which the period of response is extended to October 25, 2002 by submission herewith of a petition for a three month extension of time (and the associated fee).

IN THE CLAIMS

In accordance with 37 CFR 1.121, please substitute for claims 3 - 14 the following set of claims 7 - 9 where claims 3 - 6 and 10 - 14 are to be canceled, and claim 7 is amended. The changes to the amended claim are shown in Exhibit A attached hereto.

7. (Twice Amended) A method of making a supported mask that may be used in modifying a substrate, comprising:
obtaining a support that is not the substrate;
applying at least one layer of dielectric material to said support; and

Sub F17